## UNITED STATES PATENT AND TRADEMARK OFFICE **CERTIFICATE OF CORRECTION**

PATENT NO.

: 7,138,984 B1

Page 1 of 2

APPLICATION NO.: 09/875401

DATED

: November 21, 2006

INVENTOR(S)

: Mark W. Miles

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

On Page 4, in Column 1, under U.S. Patent Documents, line 15, delete "Adelman" and insert -- Adelmann --, therefor.

On Page 4, in Column 1, under Foreign Patent Documents, line 17, after "WO 03/073151" insert -- A1 --.

On Page 4, in Column 1, under Other Publications, line 16, delete "internet:" and insert -- Internet: --, therefor.

On Page 4, in Column 2, under Other Publications, line 21, delete "Microstructures" and insert -- Microstructure --, therefor.

On Page 4, in Column 2, under Other Publications, line 24, delete "date unknown." and insert -- (date unknown). --, therefor.

On Page 4, in Column 2, under Other Publications, line 49, delete "Capactiors" and insert -- Capacitors --, therefor.

On Page 5, in Column 1, under Other Publications, line 7, delete "Si02," and insert -- SiO<sub>2</sub> --, therefor.

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DATED INVENTOR(S) : November 21, 2006 : Mark W. Miles

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

On Page 5, in Column 1, under Other Publications, line 12, delete

"Michromachining" and insert -- Micromachining --, therefor.

In column 6, line 2, in Claim 8, delete "front surface" and insert

-- front-surface --, therefor.

Signed and Sealed this

Fifth Day of August, 2008

JON W. DUDAS Director of the United States Patent and Trademark Office